

Apogee™ Bonder

With DataStream™ Technology

Accelerate product development and lower production costs with the Apogee™ bonding system. Achieve high yield and throughput without the high cost and complexity of full automation.

Serving the Semiconductor Industry Since 1987



BENEFITS

- Substrate size range: 50–300 mm
- Dual heated platens minimize thermal defects
- Self-leveling platens minimize total thickness variation
- Evacuated bond chamber eliminates voids
- Carrier and device are separated during pre-bond evacuation
- DataStream™ technology

TOOL FEATURES & SPECIFICATIONS

- Max. temperature: 300°C
- Piston force: 550 –12,000 N
- Force resolution: 10-N steps
- Dual heated platens with independent temperature controls
- Bond chamber evacuation time: <90 seconds
- Carrier and device are separated during pre-bond evacuation
- Platen temperature uniformity: 0.3% across working surface
- Mechanical alignment fixtures are compatible with wafer notches/flats
- Alignment accuracy: ≤ 0.5 mm (dependent on substrate tolerances)

PROGRAMMABILITY

- Touch screen interface and display
- Push notifications sent to any web-enabled device
- A virtually unlimited number of user-defined recipe program steps
- 0.1-second resolution for step times (time: 0–9,999.9 s/step)
- View process status and download for offline analysis
- Process traceability for every wafer
- On-line graphical process charts and logs for piston pressure, force, temperature, vacuum, and cycle time
- Connectivity: USB/Ethernet port for communications for uploading/downloading process parameters with DataStream™ technology



RELIABILITY AND THROUGHPUT

Temporary Wafer Bonding Tool Platform Reliability

Total Throughput	Est. 14–20 WPH (process dependent)
Qualified Wafer Materials	SiC, GaN, GaAs, InP, sapphire, silicon, glass
System Uptime	>99% over 12-month period
Mean Time to Repair (MTTR)	< 24 hours
Mean Time between Failures (MTBF; hours,cycles)	>600 hours, 6,000 cycles

UTILITIES

- Electrical requirements: 208–240 VAC: 50/60 Hz, 3,400 watts (17 A)
- Nitrogen or CDA: 50 psi (345 kPa) .02 cfm (.5 liters/min)
- Vacuum pump provided: 100–120VAC,50/60 Hz

DIMENSIONS

- Bonder dimensions: 48" (122cm) W x 42.5" (108cm) D x 53.5" (136 cm) H
- Machine weight: 500 lb
- Shipping weight: 750 lb

DATASTREAM™ TECHNOLOGY: CONNECTING THE SEMICONDUCTOR INDUSTRY

DataStream™ technology gives you access to all of your connected Apogee™ manufacturing equipment in one place to track, access, and modify your systems via a web browser. This technology will give manufacturers the ability to process and visualize data in real time and search and export that data into a number of different formats.

Real-Time Process Information

- Constant feedback of process information for monitoring critical process parameters
- Streamlined interface between different tool types
- Visual cues on process status & health

Advanced Recipe Creation

- Seamless switching between basic and advanced recipe creation methods
- Plain-English recipe translation
- Pre-defined process commands
- Unlimited process steps
- Unlimited recipe storage

Environmental Monitoring

- Monitoring of temperature & humidity allows for stricter control of critical processes
- Set preconditions and tolerances for monitored parameters
- On-screen, colored visual cues for deviation from controlled specs

Data Logging & Export

- Export data logs into commonly readable formats for further analysis and process troubleshooting
- Increase process efficiency
- Identify process control deviations
- Analyze multiple processes for best known method (BKM) development

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